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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10063094	FILING DATE 03/19/2002	CLASS 427	SUBCLASS 218.1	GAU 1762	EXAMINER <i>Meek</i>
**APPLICANTS: Yang Barry; Iacovangelo Charles; Browall Kenneth; Gasworth Steven; Morrison William; Johnson James;					
**CONTINUING DATA VERIFIED: THIS APPLICATION IS A DIV OF 09/681,820 06/11/2001					
** FOREIGN APPLICATIONS VERIFIED:					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed, <input type="checkbox"/> yes <input type="checkbox"/> no		35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO RD-27190-2	
TITLE : Apparatus and method for large area chemical vapor deposition using multiple expanding thermal plasma generators					
U.S. DEPT. OF COMM./PAT. & TM-PTO-436L (Rev. 12-94)					

NOTICE OF ALLOWANCE MAILED		Assistant Examiner		CLAIMS ALLOWED	
				Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner		DRAWING	
Amount Due	Date Paid			Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE		Application Examiner	
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